

Docket No.: 2901653.11
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Charlotte Pham et alRECEIVED
CENTRAL FAX CENTER

AUG 04 2006

Application No.: 10/553,654

Confirmation No.: 7452

Filed: October 14, 2005

Art Unit: n/a

For: USE OF SILICON CARBIDE-BASED
CERAMIC MATERIAL IN AGGRESSIVE
ENVIRONMENTS

Examiner: n/a

INFORMATION DISCLOSURE STATEMENT (IDS)Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sirs:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

A copy of the International Search Report from the parent application is enclosed.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

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Application No. 10/553,654

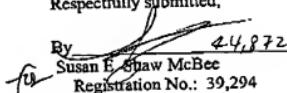
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It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

Applicant believes no fee is due with this submission. However, if a fee is deemed necessary, please charge our deposit account no. 11-0553 under order number 2901653.11, from which the undersigned is authorized to draw.

Dated: August 4, 2006

Respectfully submitted,

By 
Susan E. Shaw McBee

Registration No.: 39,294

Customer Number:

59554

BAKER DONELSON BEARMAN CALDWELL
& BERKOWITZ PC
555 11th Street, NW
6th Floor
Washington, DC 20004
202-508-3479 phone
202-508-3402 fax
Attorneys for Applicant

FTC/SB/04a/b (07-06)

Approved for use through 07/31/2005. GMB 0851-0031
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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1 Attorney Docket Number 2901653.11

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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number+Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/BMM/AA	S, 5,60,809	10-01-1998	Contellini		
AB	5,474,587	12-12-1995	Dias et al		
AC	2002/011683	01-31-2002	Gadkaree et al		
AD	4,455,385	05-19-1984	Prochazka		
AE	4,582,040	12-31-1985	Yamada et al		
AF	5,166,389	03-23-1993	Dubots		
AG	4,514,346	04-30-1985	Dias et al		
AH	5,246,424	06-12-2001	Lau et al		
AI	3,205,043	09-07-1955	Taylor		
AJ	6,342,269	01-29-2002	Yoshida et al		
AK	4,952,533	08-28-1990	Honju		

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Foreign Patent Document Country Code+Number+Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/BMM/BA	EP-0355600	03-07-1990	Shinetsu Chemical Co		
BB	FR-2808408	09-21-2001	Commissariat Energie Atomique		
BC	WO-0168560	09-20-2001	Commissariat Energie Atomique		
BD	EP-511919	11-04-1992	Pechiney Electrometallurgie		
BMM/BE	EP-1063210	12-27-2000	Ishikawajima Harima Heavy Ind		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 606. Draw line through citation if not in performance and not considered. Include copy of this form with next communication to applicant. *Applicant is to place a check mark here if English language Translation is attached. **Cite No.: The citation designation number (optional). **Kind Code: The kind code of the cited document. **Page, Column, Line: The page, column and line number of the cited document where the relevant passage or figure appears. **Page, Column, Line, Where Relevant Passages or Relevant Figures Appear: The page, column and line number of the cited document where the relevant passage or figure appears.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Date Considered
/BMM/CA	Qingwei, Huang et al, Microstructure of Reaction-Bonded Silicon Carbide, Feb, 2002 (XP-002264185)		T ²

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¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	/Brittany Martinez/	Date Considered	03/29/2009
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